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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of: Getty et al.

CASE NO.: CL2127 US NA

APPLICATION NO.: 10/817,089

GROUP ART UNIT: UNKNOWN

FILED: APRIL 2, 2004

EXAMINER: UNKNOWN

FOR: SCREENING FOR ELECTRICAL CONDUCTIVITY OF MOLECULES BY
MEASURING SURFACE POTENTIAL

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In compliance with 37 CFR 1.97 and 1.98, Applicants bring to the attention of the U.S. Patent and Trademark Office information listed on the enclosed PTO/SB/08A and PTO/SB/08B . A copy of the information is also enclosed.

Should any fee be required in connection with the filing of this Information Disclosure Statement, please charge such fee to Deposit Account No. 04-1928 (E. I. du Pont de Nemours and Company).

Respectfully submitted,

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Enclosures

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Application Number	10/817,089
Filing Date	April 2, 2004
First Named Inventor	Getty et al.
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	CL2127 US NA

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Sheet 2 of 3

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OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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